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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

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GROUP 1700

Applicants: **Chou et al.**

Case: **761 P11/CPI/L/B/PJS**

Serial No.: **10/026,378**

Filed: **December 21, 2001**

Group Art Unit: **1762**

Examiner: **M. Padgett**

Title: **METHOD OF TISIN DEPOSITION USING A CHEMICAL VAPOR
DEPOSITION PROCESS**

COMMISSIONER FOR PATENTS
Mail Stop Non Fee Amendment
P. O. Box 1450
Alexandria, VA 22313

S I R:

AMENDMENT

The following is provided in response to the Office Action dated April 14,
2003 (Paper No. 6).